



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Norikazu MIZUNO et al.

Serial No: 09/670,917

Filed: September 29, 2000

For: SEMICONDUCTOR DEVICE MANUFACTURING METHOD
AND APPARATUS FOR REMOVING SILICON NITRIDE
FORMED IN A REACTION CONTAINER (As Amended)

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an amendment in the above-identified application.

- Small entity status has been claimed. See 37 CFR § 1.27.
- A Notice Of Change Of Attorney's Address and Associate Power Of Attorney is enclosed.
- No additional fee is required.

The fee has been calculated as shown below:

	(Col. 1) CLAIMS REMAINING AFTER AMENDMENT		(Col. 2) HIGHEST NUMBER PREVIOUSLY PAID FOR	(Col. 3) PRESENT EXTRA*	LG/SM \$ ENTITY FEE		ADD'L FEE DUE
TOTAL CLAIMS FEE	19	-	20	**	0	LG=\$18 SM=\$9	\$ 0
INDEPENDENT CLAIMS FEE	4	-	3	***	1	LG=\$86 SM=\$43	\$ 86
FIRST PRESENTATION OF MULTIPLE DEPENDENT CLAIMS					LARGE ENTITY FEE = \$290 SMALL ENTITY FEE = \$145		\$ 0
					TOTAL		\$ 0

* If the entry in Col. 1 is less than the entry in Col. 2, write "0" in Col. 3.

** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space. The "Highest Number Previously Paid For" (Total or Independent) is the highest number found from the equivalent box on Col. 1 of a prior amendment or the number of claims originally filed.

- A check in the amount of \$ -0- to cover the additional claims fee is enclosed. **A copy of this sheet is enclosed.**
- A check in the amount of \$ -0- to cover the extension fee is enclosed. **A copy of this sheet is enclosed.**
- The Commissioner is hereby authorized to charge any deficiencies of fees associated with this communication or credit any overpayment to Deposit Account No. 50-1314. **A copy of this sheet is enclosed.**
- Any filing fees under 37 C.F.R. § 1.16 for the presentation of extra claims
- Any patent application processing fees under 37 C.F.R. § 1.17

Respectfully submitted,
HOGAN & HARTSON, L.L.P.

By:

Anthony J. Drler
Registration No. 41,232
Attorney for Applicant(s)

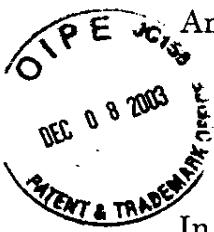
Date: December 4, 2003

Biltmore Tower
500 South Grand Avenue, Suite 1900
Los Angeles, California 90071
Telephone: 213 337-6700
Facsimile: 213 337-6701

RECEIVED
DEC 15 2003
TECHNOLOGY CENTER 2800

Application No. 09/670,917
Reply to Office Action of June 4, 2003
Amendment Dated: December 4, 2003

Attorney Docket No. 81877.0007



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Norikazu MIZUNO et al.

Serial No: 09/670,917

Filed: September 29, 2000

Confirmation No. 1895

For: SEMICONDUCTOR DEVICE
MANUFACTURING METHOD AND
APPARATUS FOR REMOVING
SILICON NITRIDE FORMED IN A
REACTION CONTAINER (AS
AMENDED)

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated June 4, 2003, the time for response to which is extended by three months by the accompanying petition from September 4, 2003 to December 4, 2003, please amend the above-referenced application as follows:

Amendments to the Claims are reflected in the listing of the claims, which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.

12/10/2003 JBALINAN 00000146 501314 09670917
01 FC:1201 86.00 DA

Art Unit: 2822

Examiner: Maria R. Guerrero

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 4, 2003

Date of Deposit

Anthony J. Oren, Reg. No. 41,232

Name



12/04/03

Signature

RECEIVED
DEC 16 2003
TECHNOLOGY CENTER
8000
